

DOCKET NO: 210313US2SRD



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
AKIRA NISHIYAMA, ET AL. : EXAMINER: MAI, A.  
SERIAL NO: 09/891,129 :  
RCE FILED: JUNE 6, 2003 : GROUP ART UNIT: 2814  
FOR: SEMICONDUCTOR DEVICE :  
HAVING AN INSULATING FILM MADE  
OF A HIGHLY DIELECTRIC THIN FILM  
AND METHOD OF MANUFACTURING  
THE SAME

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of August 15, 2003, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 7 of this paper.

**Remarks** begin on page 12 of this paper.